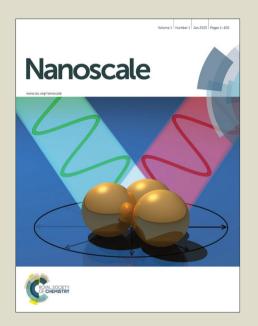
# Nanoscale

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## Nanodiamonds for Field Emission: State of The Art

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## **ABSTRACT**

The aim of this review is to highlight the recent advances and the main remaining challenges related to the issue of electron field emission (FE) from nanodiamonds.

The roadmap for FE vacuum microelectronic devices envisages that nanodiamonds could become very important in a short time. The intrinsic properties of the nanodiamond materials meet indeed many of the requirements of cutting edge technologies and further benefits can be obtained by tailored improvements of processing methodologies.

The current strategies used to modulate the morphological and structural features of diamond to produce highly performing emitting systems are reported and discussed. The focus is on the current understanding of the FE process from nanodiamond-based materials and on the major concepts used to improve their performance.

A short survey of non conventional microsized cold cathodes based on nanodiamonds is also reported.

**Keywords:** nanodiamond, field emission, vacuum microelectronics, cold cathodes.

## LIST OF ACRONIMOS

AC: alternate current

AFM: atomic force microscopy

CITS: current imaging tunneling spectroscopy

CNT: carbon nanotubes

CVD: chemical vapor Deposition

DC: direct current

EBL: electron beam lithography

FE: field emission

FEL: free electron laser

FESEM: field emission scanning electron microscopy

FET: field emission transistor

FIB: focused ion beam

HP/HT: high pressure-high temperature

HRSEM: high resolution scanning electron microscopy

HRTEM: high resolution transmission electron microscopy

RF: radio frequency

MW: micro waves

NEA: negative electron affinity

SAED: selected area electron diffraction

SEM: scanning electron microscopy

SOI: silicon on insulator

SRI: spreading resistance imaging

STM: scanning tunnel microscopy

TEM: transmission electron microscopy

UNCD: ultrananocrystalline diamond

VFET: vacuum field emission transistor

WBGM: wide band gap material

## **INTRODUCTION**

Miniaturized electron sources based on the field emission (FE) process, namely "cold-cathodes", are nowadays replacing the conventional thermoionic electron sources. The FE-based devices are able to operate at high frequency and at high current densities, have no need of heating and are characterized by reduced weight and by instantaneous switching on. Moreover, the good performances of such devices result further greatly improved by using nanostructured materials as emitters.

All started in 1968, when C.A. Spindt, on the basis of the Fowler and Nordheim studies, explaining the field emission as a quantum effect [1], fabricated the first flat display using arrays of Mo microsized cones [2]. The theoretical research work by Fowler-Nordheim and the experiments by Spindt and coworkers [3] paved the way for a number of subsequent researches on FE-based vacuum electronics. The good performances of such devices is based on the fact that, according to the Fowler-Nordheim law, the emitted current density J depends strongly on the local applied electric field E and that geometric factors, typical of nanostructures (sharp edges, tips, peaks, nanoprotrusion), locally increase the concentration of electric field at the emitter sites. The ratio of the local field to the applied field, the so-called electric field enhancement factor  $\beta$  [1], independently on the material, is a key factor influencing the field emission characteristics.

In the last two decades the design, realization and application of a new generation of cold cathodes based on advanced nanomaterials have been the object of a tremendous interest by researchers active in all the areas related to electron emission, from space applications to experiments in the field of high-energy physics. The aim was to find materials and systems characterized by the best FE performances in terms of low turn-on field (corresponding to an electron emission density of  $0.01 \text{mA/cm}^2$ ), high density of the emitted current at low applied field, robustness and long-term stability of the emission.

Among the materials most extensively investigated, carbon nanotubes (CNT) have undoubtedly a prominent place, due to their emission features and foreseen applications in advanced electronic devices [4,5]. In this regard, many efforts have been directed toward the issues of increasing the stability of the CNT field emission while decreasing the applied driving voltage. Many and different technological routes have been considered and studied. The most successful approaches proposed to generate promising starting blocks for vacuum electronic systems were the embedding of nanotubes in nonconductive polymer matrix [6] and the coating of CNT with wide band gap materials (WBGM) [7,8]. One must consider that both nonconductive matrices and WBGM coatings are able to reduce the effective work function of CNT and the turn-on field for electron emission. Moreover, WBGM coatings are expected to act as a mechanical protection for the sharp conductive emitters.

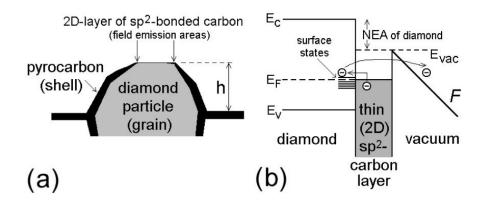
In such a framework, the use of diamond as a CNT coating to stabilize the emission has attracted the interest and attention of many research groups [9-20]. All these studies reported enhancements of the emitting features and increasing of the CNT lifetime due to the diamond coverage, and evidenced the greater potential of diamond compared with other WBGM. This could be hardly considered an unexpected result, because among the other WBGM, diamond is characterized by very favorable properties, such as high dielectric constant, a negative electron affinity (NEA), high thermal conductivity, mechanical strength, chemical inertness and radiation tolerance [21-25]. Moreover, the fact that the diamond surfaces do not adsorb chemical species made it possible to use the emitters without the need of the "conditioning" pre-treatments, consisting in complex out-gassing steps, as required in the case of uncoated CNT [26].

Let us consider in some detail the electronic structure of the diamond. Cubic diamond (s.g. Fd3m) is a semiconductor with an indirect band gap of 5.5 eV. The valence band is fully occupied, the conduction band is empty. The bare surface of diamond has an electron affinity of +037 eV, while the hydrogenated surface can reach NEA values down to about-3 eV [21;27]. Thus, the valence band of bare diamond is found at 5.9 eV, the one of the H-terminated diamond at 4.2 eV below the vacuum level. The presence of NEA in diamond influences also the work function, *i.e* the energy difference between the Fermi and vacuum level, producing a modulation of the work function values that anyhow are similar to those of graphite and other C materials (about 5 eV).

The decreasing of the diamond grain size below about 6 nm produces an increase of the band gap, due to quantum confinement effects. The size dependence of the band gap has been experimentally investigated by A Bolker et al [28].

Regarding the charge transport properties needed for electron emission, even if the diamond phase is intrinsically highly insulating, since the beginning of the "CVD diamond era" many synthetic approaches able to modulate and tailor the conducting or semiconducting behavior of diamond have been settled. As an example, it has been reported that p-type or n-type conductivities could be deliberately achieved by in situ B or N doping during the CVD growth of diamond [29-31]. A semiconductive or metallic behavior can be also achieved through the use of oxides or metallorganic compounds during the growth [32-33]. It is well known that the doping procedures introduce defects and graphitic inclusions in the diamond lattice, but in any case the CVD processes themselves provide the co-deposition of a sp<sup>2</sup> conducting phase. Also the post-synthesis procedures performed using plasma or ion beams act by inducing local phase transformation of diamond to graphite or non-diamond carbons [34,35]. This is an important issue to be taken into consideration, because the inclusion of sp<sup>2</sup> graphitic patches has strong effects on the mechanism of electron field emission from diamond. The presence of sp<sup>2</sup> phases is in particular of fundamental importance to rationalize the good field emission properties of nanodiamonds [28], that are characterized by a larger band gap with respect to bulk diamond, and would therefore be considered unattractive regarding the emission processes. The graphitic inclusions in nanodiamond deposits have a work function close to that of graphite (4.7 eV) and an energy about 1.4 eV above the valence band edge. It was indeed demonstrated [36-42] that the nondiamond carbon content is the key factor to permit an easy electron conduction from back to front surface before the emission, that preferentially occurs from sharp tips or edges of diamond nanograins. In Fig. 1[43] the scheme of a commonly accepted mechanism of emission from a coupled sp<sup>2</sup>/sp<sup>3</sup> system is presented. In this context, not only shape and size of the nanocrystalline diamonds, but also phase composition play a role.

It is to be noted that the pioneering work by Wisitsora *et al.* [44] on the emission from diamond microtips had already evidenced the effects produced on cathode performances not only by the shaping of the diamond emitters, but also by the sp<sup>2</sup> content. These authors were the first to suggest a mechanism of field emission strongly correlated to the sp<sup>2</sup> content of the diamond.



**Fig.1:** Illustrations for a field electron emission mechanism from a coupled sp<sup>2</sup>/sp<sup>3</sup> system. (a) Schematic surface structure of a diamond particle covered a pyrocarbon shell; (b) emission from the diamond surface covered with a thin graphitic layer where electrons are injected from graphite to diamond and then emit as 'diamond electrons' through the barrier, lowered due to NEA or band bending. Reprinted with permission from Ref. [43].

The emitting features shown by nanodiamond coupled with CNT have created a demand for a deeper understanding of the capabilities offered by nanostructured diamonds as effective player for fabrication of "all diamond" cold cathodes. Opportunities to exploit knowledge gained from previous investigations on the emissions from nanodiamond and related systems come especially from the rapid progress in new application areas and from the need to overcome some technological bottlenecks that other materials cannot solve, as, for example, the thermal degradation of nanotubes during emission or the effects of adsorbates on the surface of the emitters. These drawbacks, of relative importance when cold cathodes are applied in many conventional electronic devices, are expected to become strongly limiting factors in the case of less usual and most sophisticated applications. Based on the unique radiation and temperature tolerance of diamond, such electron sources can indeed work in plasmas, in high ion or neutron fluxes and in general in extreme environments, finding nowadays use in space-related applications, in nuclear reactor instrumentation and also in the driving of accelerators and free electron lasers (FEL).

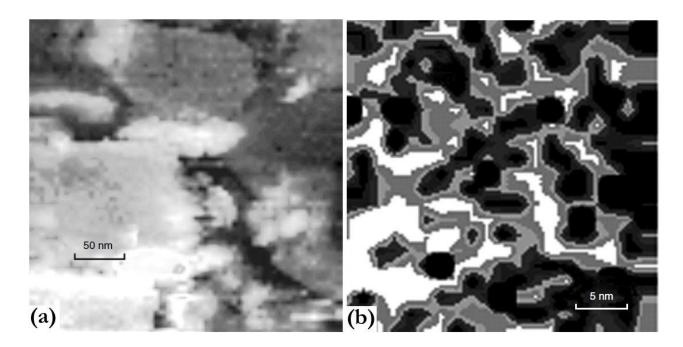
This review aims to summarize existing research, to disclose new findings and to provide a roadmap for future developments in the area of diamond-based electron field emitters. The methodologies proposed since 2000 for the production of nanosized diamond systems suitable for the assembling of cold cathodes are surveyed and discussed. A short analysis of the emitting features obtained by using the various diamond nanostructures is also given.

For the sake of clarity, the paper is organized with the following main sections: 1) Nanodiamond films; 2) Shaped diamond 1D structures; 3) Detonation Nanodiamond; 4) Nanodiamond-based devices.

## 1. NANODIAMOND FILMS

The first synthetic routes proposed for the fabrication of emitting diamond film were based on the chemical vapor deposition (CVD) techniques, still widely employed for preparation of nanocrystalline layers that can be easily integrated in Si circuit technology. In view of the fact that morphology and structure of the films depend strongly on the composition of the feeding gas, a variety of gas mixtures has been used to modulate the characteristics of the carbon deposits in terms of crystallinity and phase purity. A review reporting on the CVD growth of nanodiamond films has been published in [45].

A specific class of nanodiamond films is the so-called ultrananocrystalline diamond (UNCD), firstly produced at the Argonne National Laboratory [46-48] using a hydrogen-poor plasma chemistry. The inert gases (N<sub>2</sub>, Ar, He, ...) added to the feeding gas phase play an important role by accelerating the high secondary nucleation rates, and the control of the H<sub>2</sub>/noble gas ratio enables to produce nanocrystalline films with grain size in the 2-5 nm range. The group headed by D.M. Gruen further optimized the deposition methodology, using mainly N for the doping and obtaining films with a high degree of conformality and very exciting FE properties [49-55]. Deep analysis of the films performed by means of complex scanning probe microscopy methods evidenced in such films periodic structures where diamond crystallites were associated to high-conducting inclusions. AFM in Spreading Resistance Imaging (SRI) configuration allowed to obtain the maps of the conductivity along the film nanostructure. As a general rule, conduction in UNCD occurs at the grain boundaries, where the N incorporation produces graphitic nanoregions. The images reported in Fig. 2 evidence the distribution of the highly conductive inclusions, corresponding to the nanoregions where emission occurs at the lowest field values.

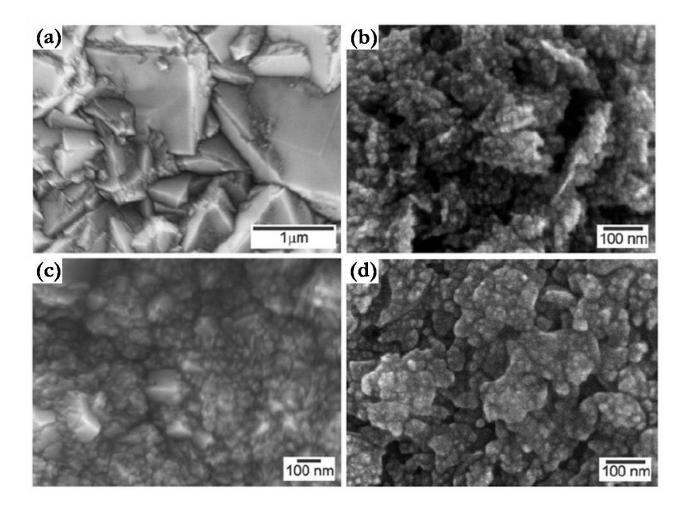


**Fig.2:** Samples grown with  $10\% N_2$  in the plasmas: (a) AFM-SRI map ( $320 \times 320 \text{ nm}^2$ ); (b) AFM-SRI map ( $25 \times 25 \text{ nm}^2$ ) showing the distribution of the film electroconductivity inside conglomerates. Reprinted with permission from Ref. [50].

A series of experiments have been designed and carried out in laboratories around the world to study the relationship between the FE features and some fundamental parameters, such as the sp<sup>3</sup>/sp<sup>2</sup> ratio, the grain size and shape, the doping level, and the patterning. The low dimensionality of the grains and the shaping in elongated 1D structures were found to definitely represent the key parameters for a significant emission from diamond films. However, a critical analysis of the data indicates that several other aspects play a role.

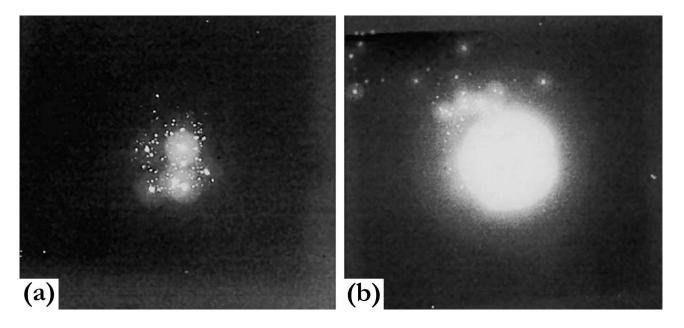
Regarding the topic of doping, many papers analyzed in details the effects produced by adding nitrogen to the gaseous mixtures used for the synthesis on diamond nanostructure and emission efficiency [56-60]. A general conclusion that can be drawn from the above reported studies is that the nitrogen-incorporation into diamond not only induces a n-type conductivity, but also provides the formation of sp² hybridized carbon, that plays a fundamental role in FE from carbon nanostructures [40]. The insertion of nitrogen in the diamond lattice is generally achieved by adding N₂ to the gaseous feeding mixtures used for the CVD-based growth, but in some cases also different nitrogen sources have been used. As an example, nitrogen-doping could be obtained in [58] by using urea (NH2CONH2) in powder form, carried by gas fluxes and delivered to the active area of the deposition chamber by a tubing system. The use of urea as a reactant has proved to generate a larger amount of NV defects with respect to those induced by the use of N₂. Such defects are claimed as very effective for the generation of a donor band in diamond state [58], and the coupling of this donor band with the conductive sp² channels leads to the enhancement of the emission properties.

In other experiments, the addition of He was found to produce layers with structure varying from nanocrystalline diamond with graphitic patches connecting the grains, to porous interconnected graphenes networks [62,63]. Fig. 3, shows the various morphologies obtained by He concentrations of 10%, 20%, 30% and 40%, respectively.



**Fig.3:** Typical 'top-view' FESEM images of the samples after deposition for 3 h at different helium concentrations in the gas feed: (a) 10 vol%, (b) 20 vol%, (c) 30 vol%, and (d) 40 vol%. Reprinted with permission from Ref. [63].

A methodology based on the plasma-aided chemical deposition from CH<sub>4</sub>/H<sub>2</sub>/N<sub>2</sub> mixtures activated by a DC discharge has been reported in [64]. A series of nitrogen-containing nanodiamond films lacking of any significant difference in phase composition and morphology were produced. Conversely, marked differences (up to 200 times) were found when comparing the values of emitted current from the various samples. This occurrence has been ascribed to needle-like carbon nanofibers present on the surface of the films produced at higher temperatures. In **Fig. 4** is reported an impressive image showing the marked differences in the density of emitting centers for samples grown at 950 °C and at 1030 °C [64].



**Fig.4:** Photographs of the screen (imaged area: 20×20 mm²) showing the distribution of the FE centers on the cathode surface for samples prepared with a substrate temperature of: (a) 950 °C; (b) 1030 °C, respectively. Reprinted with permission from Ref. [64].

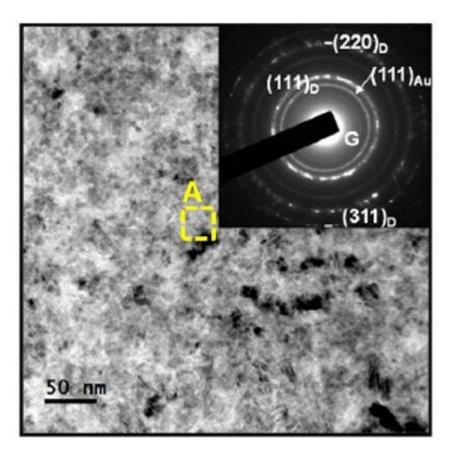
Nano-graphite filaments were found to play a role in the emission process also by Cheng et al. [65], while they were investigating the FE characteristics of diamond films produced by two different bias-enhanced-nucleation and bias-enhanced-growth approaches, namely processes. investigations enabled to settle the plasma conditions for production of films with turn-on field as low as 3.6 V/ $\mu$ m, and able to emit current densities up to 325  $\mu$ A/cm<sup>2</sup> at applied field of 13.5 V/ $\mu$ m. The good FE performances have been rationalized on the basis of the unique structure of the nanocrystalline diamond deposits (grains size: 10-30 nm), that were found to contain large proportion of SiC particulates, likely produced by plasma-induced ion bombarment of the Si substrate. The growth of the SiC nanoparticulates was accompanied by that of nano-graphite filaments, around 5 nm in thickness and several tens nanometer in length. The presence of such nanographitic phase, extending all over the diamond film, greatly facilitate the electron transport through the film, and is considered the key factor improving the FE performances of these films with respect to those grown from conventional CH<sub>4</sub>/Ar plasmas.

An approach based on properly bias-enhanced CH<sub>4</sub>/Ar plasmas was found to greatly accelerate the nucleation and growth processes, producing by 10 min runs UNCD films with thickness up to 380

nm [66]. The employed synthesis methodology induced the formation of graphitic nanoregions distributed inside the diamond film and at the interface, forming a network of conductive paths that facilitate the electron transport and the field emission process. The nanostructured films were used to assemble high-performance cold cathodes.

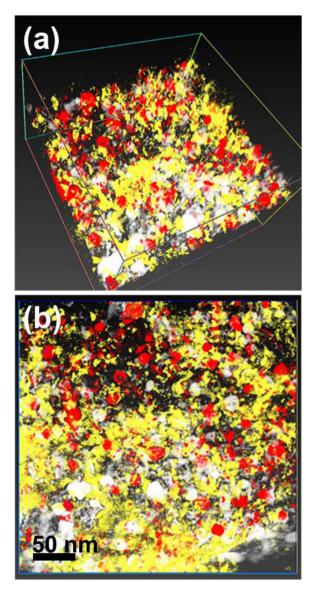
High current emission was obtained from thin diamond films deposited by an innovative MW plasma-assisted CVD reactor adding both Ar and  $N_2$  to  $CH_4/H_2$  mixtures. Current densities up to 220 A/cm<sup>2</sup> were emitted under 50 ns high-voltage pulses with amplitude up to 100kV. These highly efficient cathodes were successfully tested in high-power pulsed RF compressor triggered by an electron beam [67].

In the search of methodologies able to increase the conductivity and enhance the FE, some research groups explored the strategy of metal-ion implantation in nitrogen-doped ultrananocrystalline diamond films. By implantation of Au and Cu ions in diamond films grown at rather low temperatures (T< 475 °C), Sankaran *et al.* produced free-standing, highly conducting films with emitted currents up to 3.76 mA/cm² at applied field of 12.5 V/ $\mu$ m [68]. Afterwards, diamond films characterized by a conductivity up to a value of 185  $\Omega$ <sup>-1</sup>cm<sup>-1</sup>, low turn-on field (4.88 V/ $\mu$ m) and by a current density of 6.52 mA/cm² at an applied field of 8.0 V/ $\mu$ m were produced by Au impiantation [69]. The TEM images of **Fig. 5** show dispersions of Au nanoclusters at the film/substrate interfaces. The outstanding emission features have been ascribed to the Au-induced formation of nanographitic patches at the grain boundaries of the polycrystalline films, and to the opening of effective conducting channels for electron transport. A slightly reduced improvement of both electrical conductivity and electron emission was instead obtained when Cu-ions were implanted in the same type of ultrananocrystalline diamond layers. From these films current densities up to 3.60 mA/cm² at applied field of 8.0 V/ $\mu$ m were measured [70].



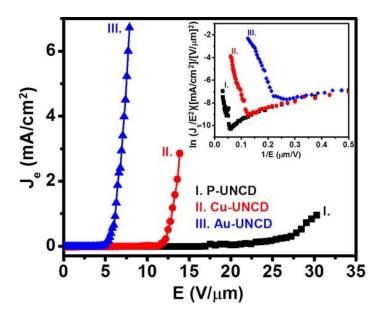
**Fig.5:** TEM image of Au nanoclusters at the film/substrate interfaces with corresponding SAED pattern shown as inset. The spotted diffraction pattern arranged in ring indicate the nano-sized nature of the diamond and the gold phases. Reprinted with permission from Ref. [69].

Interesting FE properties, with a turn on field of 1.98 V/ $\mu$ m and current density of 705  $\mu$ A/cm² at 7.5 V/ $\mu$ m, were revealed in the case of nitrogen-containing UNCD films that were Fecoated and post-annealed at 900 °C in H<sub>2</sub> atmosphere [71]. These films were characterized by a unique granular structure formed by diamond grains (sizes <5 nm) and uniformly distributed dense population of Fe nanoparticles, produced from the H-induced annealing of the Fe coating. The morphological features of the Fe nanodeposits can be observed in **Fig. 6**, that shows the stereographic projection and the X-Y projection of the TEM 3D-tomography. The process of Fe clustering induced, in turn, the formation of graphitic nanoregions surrounding the nanoparticles. The preferential emission of electrons from the graphitic regions was demonstrated by performing current imaging tunneling spectroscopy, that evidenced enhancement of the FE from the boundaries of the Fe nanoparticles.



**Fig.6:** (a) Stereographic projection and (b) X-Y projection of the TEM 3D-tomography of (Fe/UNCD)<sub>900</sub> film. Reprinted with permission from Ref. [71].

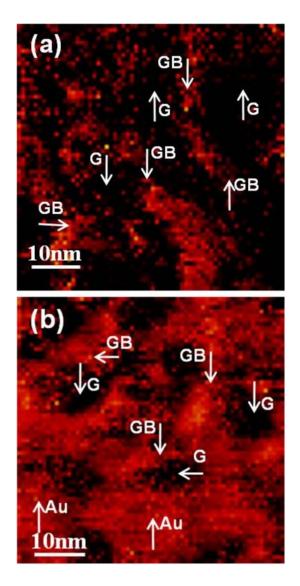
A comprehensive investigation on the relationship between structure of the implanted UNCD films and emission behavior has been carried out in [72]. In both the Au- and Cu-implanted layers the SEM investigation evidenced pronounced morphological changes induced by the ion implantation, with modifications from an equi-axed granular structure, typical of pristine UNCD films, into a featureless morphology [72]. In **Fig.** 7 the field emission curves of the pristine UNCD, of the Cu-UNCD, and of the Au-UNCD films are reported along with the corresponding Fowler-Nordheim plots.



**Fig.7:** Electron field emission properties (J<sub>e</sub>-E curves) of: (I) pristine UNCD; (II) Cu-UNCD; (III) Au-UNCD films. The inset shows the corresponding Fowler-Nordheim plots. Reprinted with permission from Ref. [72].

The mechanism behind the enhanced FE properties of both the Au- and Cu-implanted UNCD films has been rationalized taking into account the results of the structural characterizations, that evidenced, in all the samples, the formation of metallic nanoclusters homogeneously distributed in the films. However, differences were found in the shape of the Au and Cu nanoclusters. Whereas implanted Au ions were found to form spherically shaped Au nanoparticles, HRTEM investigations revealed plate-like Cu nanoparticles arranged in row-like patterns. The morphological features of the Au and Cu clusters were found to modulate the proportion of nanographitic phases at the grain boundaries of the nanodiamond film. Rather larger amounts of nanographitic phases were detected at the Aunanodiamond grain boundaries with respect to those surrounding the Cu clusters, and this finding can explain the better emission performance exhibited by the Au-implanted diamond films.

The role of the graphitic phases surrounding the diamond nanocrystallites in improving the emission has been directly confirmed by current imaging tunneling spectroscopy (CITS). **Fig. 8**, taken from [72], shows the local electron emission behavior and evidences that electrons are prevalently emitted from the grain boundaries.



**Fig.8:** CITS image of: (a) Cu-UNCD; (b) Au-UNCD films. The typical grains and grain boundaries are marked as "G" and "GB", respectively. Reprinted with permission from Ref. [72].

## 2. 1D STRUCTURES

Starting from the systematic investigations of Wisitsora *et al.* [44], it has been demonstrated that the FE from nanodiamond films could be strongly enhanced by shaping diamond in form of elongated low-dimensional structures, such as nano-rods, nano-wires, nano-tips, nano-whiskers and nano-pillars. The energetic stability, theoretical aspects and preferable morphology of the diamond 1-D nanostructures have been deeply investigated by A. Barnard in [73].

The increase of the emission properties in sharpened diamond has been commonly ascribed to the formation of tips and to the related increase of the field enhancement factor  $\beta$  [74]. The idea underlying such interpretation is that the lines of the applied field concentrate at the tips, lowering the barrier for electron emission. However, the nanometric control of diamond materials into the desired and tailored geometries, as the ones required for fabrications of cold cathodes, is really a challenging and complex task.

1-D shaped nanodiamond systems have been and are still fabricated by several methods, including top-down lithographical approaches [75,76], bottom-up growth using chemical vapor

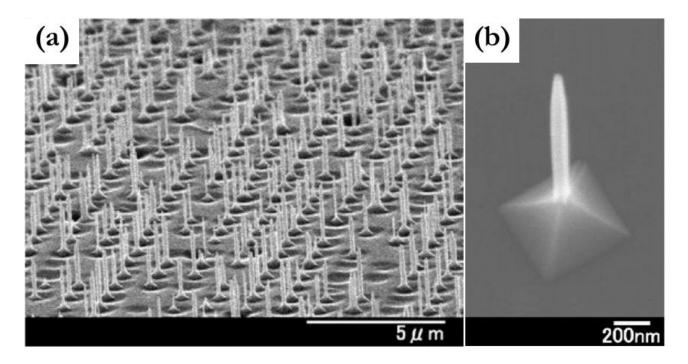
deposition CVD with templates [77], plasma-aided CVD growth without spatial confinement [25,78,79] and plasma post- synthesis treatments.

Among the various methodologies proposed for the diamond shaping into pointed structures, the most successful and more widely used are based on the plasma treatments of plane diamond films. Using such approaches it is possible to produce both polycrystalline and single-crystal 1D structures, with diameters spanning several tens of nanometers.

There are many options for the plasma etching of materials. The shaping of diamonds in pointed structures able to offer high emission efficiency can be successfully performed using plasmas generated by different sources, such as radio-frequency (RF), micro-wave (MW), direct current (DC), electron cyclotron resonance (ECR), inductively coupled plasma (ICP), neutral loop discharge (NLD) [80-83]. In some cases plasmas produced by the coupling of two different sources are used. All these sources are capable of delivering high density plasmas and can provide an efficient and reliable way to fabricate diamond—based micro- and nano-structures.

The first studies on the etching of diamond were performed on HP/HT single-crystal samples using an O<sub>2</sub>/H<sub>2</sub> RF plasma [84]. Starting from 1990, several studies addressed the use of a suitable gas or of gas mixtures to realize plasma treatments of single-crystal or polycrystalline diamond flat plates [34,85], obtaining nanowire arrays with or without applying a mask. These findings opened the way for the design and fabrication of pointed diamond nanostructures also for emitting purposes.

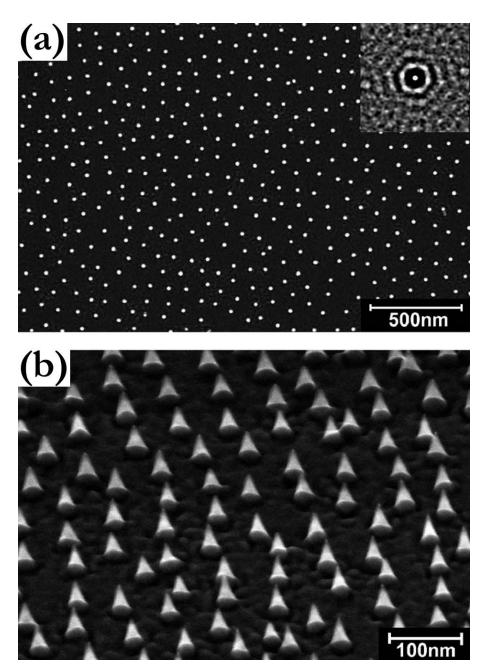
By using a mask and CH<sub>4</sub>/O<sub>2</sub> RF plasma Ando *et al.* [86] produced high quality single-crystal diamond nanorods on a (100) oriented diamond crystal. **Fig. 9** shows SEM images of an array of diamond nanorods and details of a single crystalline nanorod.



**Fig.9:** SEM micrographs of H-plasma treated HP-HT synthetic diamond with (100) surface: (a) an array of diamond nano-rods; (b) an isolated nano-rod. Reprinted with permission from Ref. [86].

Aligned diamond nanowires were obtained by Smirnov et al. [87] using self-aligned Ni nanoparticles as mask and carrying out the etching using an oxygen inductive coupled plasma.

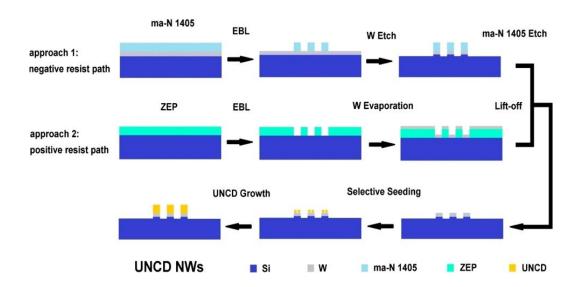
The combination of a strongly anisotropic  $O_2/CHF_3$  plasma etching with a hexagonally patterned nanomask made by Au nanoparticles was the approach used in [88] to produce the densely packed arrays of diamond nanotips shown in **Fig. 10.** The emission was found greatly enhanced with respect to the emission from untreated pristine B-doped diamond films.



**Fig.10:** SEM pictures of a diamond surface nanostructured by combining self-assembled micellar Au nanomasks with anisotropic reactive ion etching: (a) top view; (b) sample tilted by 50° relative to surface normal. The inset of (a) gives the lateral correlation function indicating a high degree of hexagonal order. Reprinted with permission from Ref. [88].

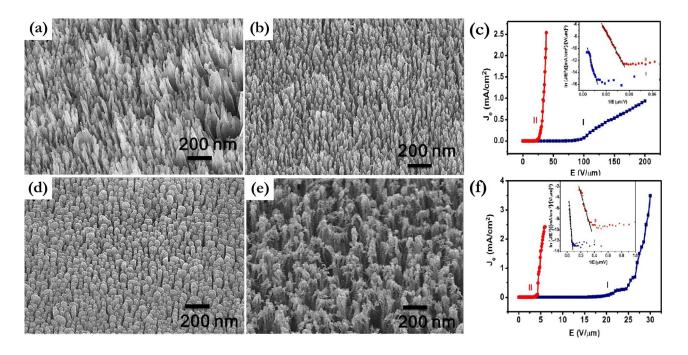
An upsurge of publications related to mask-free processes for fabrication of very efficient diamond emitting systems occurred in the last few years.

A forest of straight diamond rods longer than 6  $\mu$ m have been fabricated by etching a polycrystalline diamond film in an  $O_2$  RF plasma reactor [89]. Each of the shaped rods was found formed by two conical single crystalline diamond grains. Ref. [76] illustrated a modified bottom-up EBL/RIE method based on selective seeding RIE process, that enables the growth of horizontally aligned ultrananocrystalline nanowires (width about 90 nm) at pre-defined positions of the substrate. The scheme of the process is shown in **Fig. 11**.



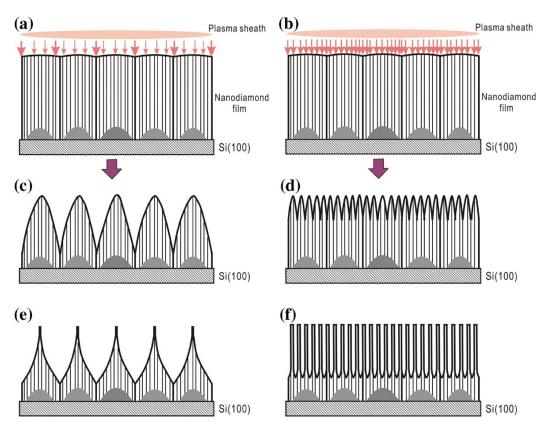
**Fig.11:** Schematic of ultrananocrystalline diamond nanowires fabrication processes by a modified bottom-up EBL/RIE method based on selective seeding by both RIE and lift-off. Reprinted with permission from Ref. [76].

A series of uniform and high density nanostructures have been selectively engineered from diamond films characterized by a variety of granular morphologies [90]. Cone-shaped and tip-shaped nanostructures were obtained from microcrystalline diamond using a CF<sub>4</sub>/O<sub>2</sub> plasma, conversely pillar-like and grass-like forms from nitrogen-doped ultrananocrystalline diamond using an Ar plasma. The authors deeply investigated the relationship between structure/morphology of the nano-shaped deposits and important functional properties, such as photoluminescence and electron emission. In **Fig. 12** can be observed the different morphologies of the nanostructures obtained by RIE etching of microcrystalline films (a), from nanocristalline films (b), from ultrananocrystalline films (c) and from nitrogen-doped ultrananocristalline films (d). The corresponding FE curves are also reported. It is evident that the most appealing FE properties are exhibited by the nanosized diamond forms originated from UNCD.



**Fig.12:** FE-SEM micrographs of 30-min RIE etched nanostructures: (a) nanocones from microcrystalline films; (b) nanotips from nanocrystalline films; (d) nanopillars from ultrananocrystalline films; (e) nanograss from nitrogen-doped ultrananocrystalline films. The corresponding FE curves are also reported: (c) nanocones (curve I) and nanotips (curve II); (f) nanopillars (curve I) and nanograss (curve II). Reprinted with permission from Ref. [90].

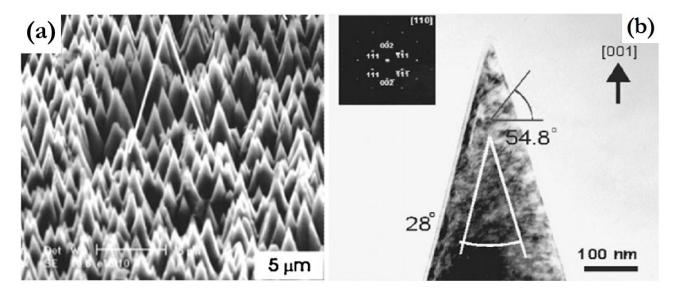
Hydrogen plasmas have been and still are widely used to etch diamond films. As already evidenced in early studies on plasma-treated diamond [35,91], the effect of the etching, dependent on the orientation of the diamond nanocrystallites, is enhanced when a negative DC bias is applied. The mechanism acting in the formation of sharpened diamond structures by negative biased plasmas is briefly schematized in the following. The hydrogen ions generated by the plasmas, whenever the plasma source is, are accelerated by the electrical field and compelled to stream downward to the sample surface. The electrons emitted from the diamond film produce a modification in the plasma configuration. The resulting inhomogeneous distribution of the electrical field lines induces a more intense ion impact at the grain boundaries, where sp² nanodomains or defective sp³ clusters are confined. The resulting effect is a preferential etching of the grain boundary zones and a subsequent coming up of vertically elongated nanostructures. Depending on the plasma conditions, and specifically on the kinetic energies of the ions, a variety of columnar nanoshaped diamond deposits can be obtained. A schematic diagram that illustrates the etching process induced by a H₂/Ar plasma under negative bias has been proposed by Zou et al. [92]. The scheme depicted in Fig. 13, in its general lines, can be considered valid also for plasmas generated by other gases.



**Fig.13:** Schematic representation of the bias-assisted RIE process on polycrystalline diamond films. The inhomogeneous distribution of the electrical field causes a preferential impact of the ions at the boundaries, as denoted by the arrows in (a) and (b) for the low and high ion kinetic energies, respectively. As a result, different surface morphologies are structured at the RIE conditions of: (c) and (d) low and high ion kinetic energies in H-plasmas, respectively; (e) and (f) low and high ion kinetic energies in H<sub>2</sub>/Ar plasmas, respectively. Reprinted with permission from Ref. [92].

The treatments in H-plasmas not only act by shaping flat diamond plates, but can be also viewed as a feasible solution to hydrogenate the diamond surface, modifying and tailoring the intrinsic NEA of diamond. A lowering of the electron emission barrier due to the hydrogen-terminated diamond surfaces induced by the H-etching was measured in [92-94]. The investigation of the NEA in H-etched polycrystalline samples revealed that high electron intensities were emitted from defective sites or graphitic/amorphous phases confined in grain boundaries, confirming that the electric field was unevenly distributed over the diamond surface [93,94].

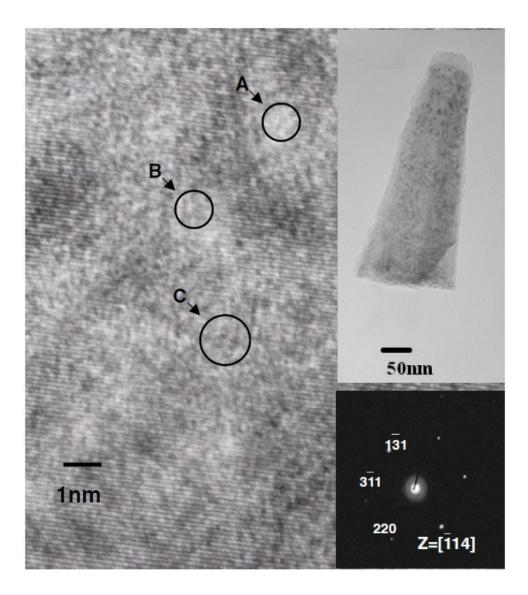
The bias-assisted H-etching can provide nanocone arrays with high aspect ratio, sharp tips, and high uniformity in geometry and size over a large area. **Fig. 14** shows the SEM image (**Fig. 14-a**) of an array of diamond nanocones produced by plasma etching of nanosized grains [95] and the TEM image (**Fig. 14-b**) detailing dimensions and single-crystal nature of a single nanotip. As reported in [95], the turn-on fields were 26.9, 6.2, 18.2, and 10.1V/μm for the pristine flat nanocrystalline diamond film, a low-density nanocone array, a high-density nanocone array, and an array of single-crystal diamond nanocones, respectively. The significant reduction of the turn-on field by lowering the nanocone density from 10<sup>8</sup> cm<sup>-2</sup> to 10<sup>6</sup> cm<sup>-2</sup> is likely due to the elimination of the screening effect acting between adjacent emitters.



**Fig.14:** (a) SEM images of a single-crystal diamond cone array; (b) TEM image of a diamond nanotip showing the sharp and single-crystal nature. The inset is the corresponding SAED pattern. Reprinted with permission from Ref. [95].

Sharp tips (radius as small as 2 nm) are easily obtained by the action of energetic H ions impinging at right angle on the negatively polarized substrate. The formation of nanocones by Hetching follows, as a general rule, the following steps. The removal of the material starts from the grain boundaries, and the process proceeds by sharpening the isolated nanograins, up to obtain final conical features as a consequence of an etching rate faster across the height of the gradually protruding diamond structures [95-97].

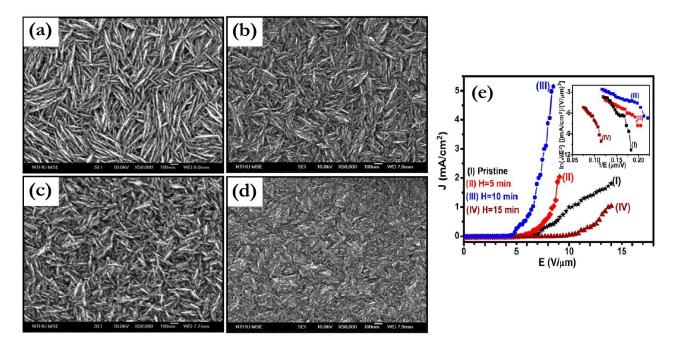
A programmed treatment consisting in nitrogen plasma immersion ion implantation was carried out on crystalline diamond nanotips (~1 µm in height,~200 nm bottom diameters) produced by MW-enhanced CVD [78]. After the nitrogen treatment a turn-on field of 3 V/µm and a current density up to 4 mA/cm² at applied field of 9 V/µm were measured. HRTEM observations of the crystalline elongated objects evidenced nanosized amorphous regions, due to the disruption of sp³-coordinated bonds and subsequent creation of structural defects induced by the accelerated N-ions (**Fig. 15**).



**Fig.15:** HRTEM lattice image of a diamond nanotip treated with nitrogen plasma immersion ion implantation for 10 min. A clear lattice image with several nanoscale amorphous regions circled and marked by 'A', 'B' and 'C' is observed in a crystalline diamond crystal structure. The bright-field HRTEM image of the diamond nanotip is inserted in the upper-right corner. The electron diffraction pattern of the diamond nanotip is inserted in the lower-right corner. Reprinted with permission from Ref. [78].

On the basis of several similar results published in the same years, it has been suggested that the good emission exhibited by the sharpened diamond deposits could be ascribed to both the high aspect ratio geometry and to the electron conducting pathway in the C-sp<sup>2</sup> layer [98]. This interpretation opened a new scenario. Even if the protruding sharp structures certainly increase the field enhancement factor  $\beta$  [1] by concentrating on themselves the field lines, only a little evidence there was at that time that electrons were emitted from such sharp tips. Wide confirmation was instead accumulated on the presence of graphitic phases. The surface of sharp structures generated by various techniques or plasma etching, are always found coated by thin layers of amorphous carbon with high sp<sup>2</sup> content.

Recently, Panda et al. [99] produced diamond nanowires by H-plasma etching of nitrogencontaining diamond films generated by a MW-CVD process. The H-plasma treatments produced wirelike diamond nanocrystals encased in a nanographitic sheet (**Fig. 16-a** ) with turn-on fields of 4.2 V/ $\mu$ m, and current densities up to 5.1 mA/cm² at applied field of 8.5 V/ $\mu$ m. The systematical investigation of the effect of H-etching on both FE and conductivity (up to 216  $\Omega$  cm¹) evidenced a strong enhancement of the emission properties produced by rather short H-plasma treatment times (<10 min). Conversely, a degradation of the same properties was found to occur for etching processes longer than 15 min, as one can see from the FE data reported in **Fig. 16-b**. This has been imputed to the removal, induced by a prolonged H-etching, of the graphitic phase surrounding the diamond nanowires [99].



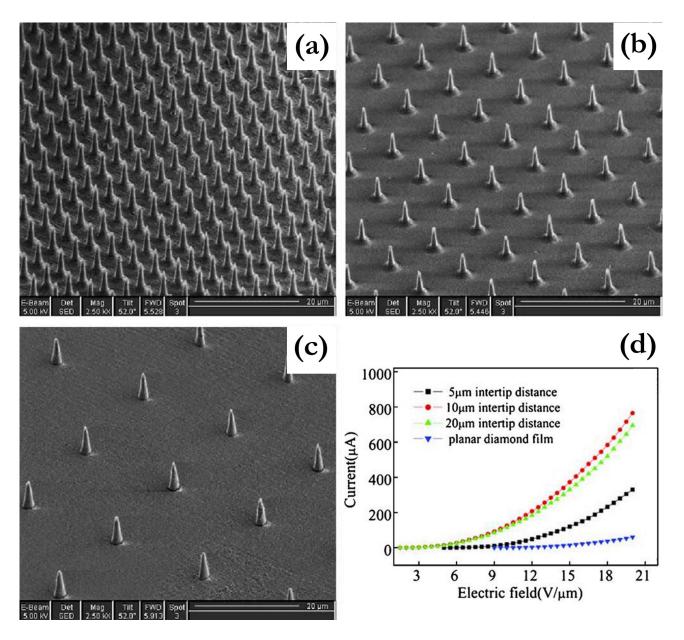
**Fig.16:** FESEM images of: (a) pristine and (b-d) H-plasma-treated diamond nanowires for: (b) 5, (c) 10; and (d) 15 min. The field emission current density (J) as a function of applied electric field (E) is reported in (e) for: (I) pristine; (II) 5 min; (III) 10 min; and (IV) 15 min H-plasma-treated films. The inset presents the corresponding F-N plots. Reprinted with permission from Ref. [99].

A direct observation of the emitting sites in plasma shaped diamond samples has been recently achieved by Chatterjee *et al.* [100] by employing a STM apparatus. The results reported in [100] confirm the hypothesis that the emission occurs mainly from the non-diamond phases located at the grain boundaries between the pointed nanostructures.

Another suitable option to prepare cone-shaped diamond nanostructures is that of using the focused ion beam (FIB) technology. As reported in [101] high aspect ratio nanocone arrays with controlled densities could be produced via FIB milling of a freestanding un-doped diamond film characterized by a moderate content of sp<sup>2</sup> carbon. The emission from the nanocone arrays reached 88  $\mu$ A at 15 V/ $\mu$ m. Emission from the back surface of the same film only reached 10  $\mu$ A at 15 V/ $\mu$ m. The authors estimated that the average emission current from an individual diamond cone with apex radius of about 60 nm was about 13 nA. Under the assumption of electrons mainly emitted from the hemispherical apex, the average current density per cone would be 5.8 x 10<sup>4</sup> mA/cm<sup>2</sup>.

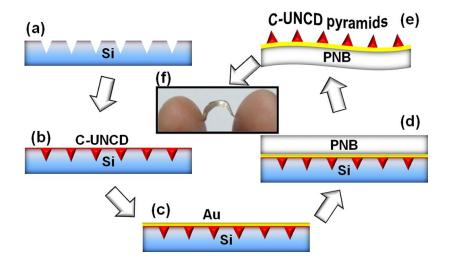
A study on the FE as a function of the inter-distance between tips has been carried out in [102]. Fig. 17 (a,b,c) shows SEM images of nanotips arrays with inter-tip distances of 5, 10 and 20 µm. Fig 17-d

reports the current intensity as a function of the applied field for the 3 different nanocone arrays and for the pristine planar film.



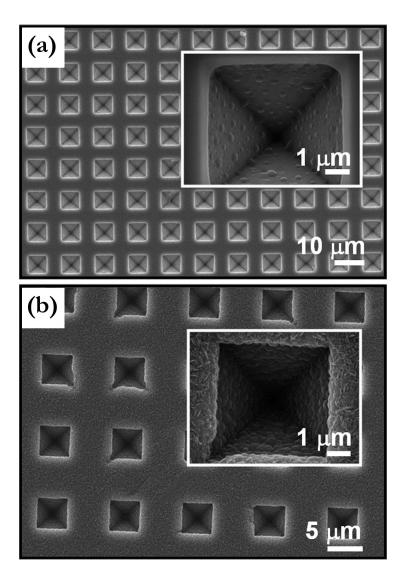
**Fig.17:** SEM images of high aspect ratio conical diamond tips arrays on the freestanding diamond film. The corresponding inter-distances of tips are: 5  $\mu$ m (a), 10  $\mu$ m (b), 20  $\mu$ m (c), respectively. In (e) the (*I-E*) curves of field emission from the conical diamond tips arrays with different inter-distances and the one from the planar diamond film are reported. Reprinted with permission from Ref. [102].

Further explored strategies regard the incorporation of nanosized diamonds inside specifically configurated substrates. An example of such fabrication approach is illustrated in [103]. Here arrays of pyramidal shaped UNCD microtips, produced by depositing conductive nanodiamonds inside inverted pyramidal microcavities, have been applied on a plastic substrate. **Fig. 18** illustrates the scheme of the fabrication process.



**Fig.18:** Schematics of the process for fabricating flexible C-UNCD pyramidal microtips: (a) anisotropic etching of the Si substrates using potassium hydroxide: normal propanol: deionized water solution to form inverted pyramidal microcavities; (b) deposition of C-UNCD films on inverted pyramidal microcavities using the microwave plasma chemical vapor deposition system; (c) sputtered deposition of Cr (5 nm) and Au (100 nm) on C-UNCD films; (d) spin coating of polynorbornene (PNB); (e) arrays of flexible C-UNCD pyramidal microtips after etching of Si; (f) the digital photograph of typical hand bent, flexible C-UNCD pyramidal microtips. Reprinted with permission from Ref. [103]

**Fig. 19** shows a typical array of inverted pyramidal microcavities homogeneously coated by nanodiamond. For arrays of 2 μm tips, a turn-on field of 1.80 V/μm and a current density of 5.8 mA/cm² at an applied field of 4.20 V/μm have been measured [103]. Flexible devices based on the diamond pyramidal microtips open a prospect for a new generation of flat panel displays and high brightness electron sources.



**Fig.19:** FESEM image of: (a) typical arrays of inverted pyramidal microcavities created on Si substrate with the inset showing magnified images of a single inverted pyramidal microcavity; (b) the C-UNCD films coated inverted Si pyramidal microcavities with the inset showing the magnified images of a C-UNCD films coated single inverted pyramidal microcavity. Reprinted with permission from Ref. [103].

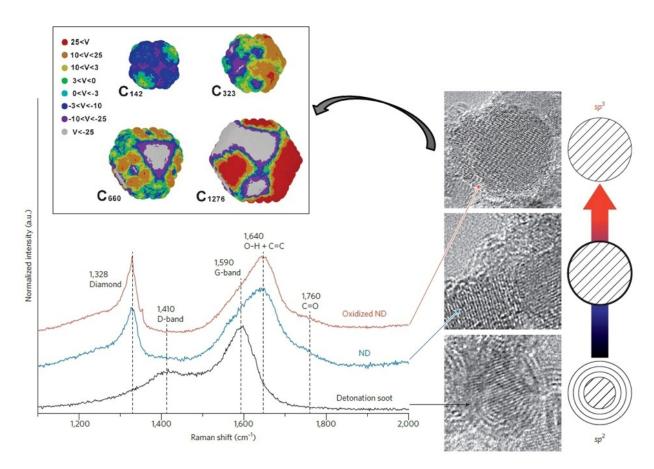
Plasma-assisted CVD growth proved to be a viable approach to produce, without the use of a mask, ensembles of sharpened diamond forms directly during the synthesis step. In [79] diamond nanocone arrays were produced using CH<sub>4</sub>/H<sub>2</sub> mixtures in a bias-enhanced dual-mode RF-MW plasma reactor under well controlled conditions. The H-ion bombardment led to localized conversion of the growing diamond to graphitic or amorphous phases, which were further chemically etched by the activated hydrogen species in the plasma. The conical shaped structures are the result of an interplay between competing growth and etching processes.

## 3. DETONATION NANODIAMOND

In the context of nanodiamond materials employed to assemble cold cathodes, a specific mention must be given to the so called "detonation nanodiamond" [104]. In this case the nanodiamond, in powder form, is extracted from the soot produced by a detonation process. The first published

papers on detonation nanodiamond [105,106] at once evidenced the attractiveness of this member of the crystalline carbon family and inspired researchers to perform investigations regarding also the emission properties. With respect to the electron emission, detonation nanodiamond shows indeed some advantages over CVD generated and/or plasma etched nanodiamond deposits [107].

One must consider that nanodiamonds are polyhedral objects (crystallites with sizes in the 4-6 nm range), with distinct faceting. It has been reported how the polyhedral shape affects the stability of the surface of small particles, including the graphitization of the surface to form fullerenic bubbles. This instability gives rise to a sp<sup>3</sup> core surrounded by an external shell of sp<sup>2</sup> carbon. HRTEM images (taken from Ref. 104) of typical detonation soot, purified nanodiamond and oxidized nanodiamonds are shown in **Fig. 20**. The diamond peak of the purified (blue line) and oxidized (red lines) nanodiamonds can be seen at 1328 cm<sup>-1</sup> in the Raman spectra. A further important aspect of this kind of nanodiamond is the presence of surface electrostatic potential, that changes with particle size, and induces the formation of agglomerates with a preferred particle/particle orientation and drives the assembly of nanodiamond with other chemical species [108-112]. A sketch of the normalized surface electrostatic potential for relaxed structures of cuboctahedral shaped nanodiamonds is reported in the inset in **Fig. 20**. The sketch has been illustrated in [108], where a deep discussion on the physical properties of the nanodiamond surfaces can also be found.



**Fig.20:** Electron micrographs showing detonation soot (bottom), purified nanodiamond (middle) and oxidized nanodiamond (top). The diamond cores in purified nanodiamonds are partially covered by a thin layer of graphite, that allows to observe the diamond peak at 1328 cm<sup>-1</sup> in the Raman spectrum (blue line). In the inset the normalized surface electrostatic potential for relaxed structures of cuboctahedral shaped nanoparticles is shown. Adapted and reprinted with permission from Ref. [104] and [108].

The intrinsic core/shell architecture of detonation nanodiamonds converts into a practical form the concept of sp<sup>2</sup>/sp<sup>3</sup> mixture that was definitely found to govern field emission from carbon nanostructures. Moreover, differently from the as-produced CVD films, the nanosized polyhedral crystals of detonation diamond offer spontaneously a large number of sharp edges, eliminating the need of etching treatments [111].

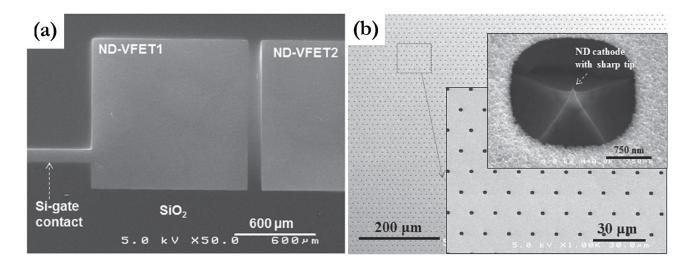
The first results on the use of detonation nanodiamond as cold emitter material were presented in dedicated conferences and published in widespread books [113–115]. After the first intense phase of investigations addressed to establish the emitting features of this exciting new nanomaterial, detonation nanodiamond can be considered now a rather "mature" emitting material, on which carry out activities of applied research for cathode prototyping and technological transfer [112].

## 4. NANODIAMOND-BASED DEVICES

Effective downscaling and microintegration of emitting systems, coupled with substantial advances in novel cold cathode geometries, are offering brilliant solutions for a variety of rapidly evolving technologies.

Vacuum integrated circuits based on nanodiamonds are nowadays proposed by several research groups. Hsu *et al.* [116] fabricated a vacuum field emission transistor (VFET) based on nitrogen-incorporated nanodiamonds. The diamond phase was deposited by CVD on cavities patterned on silicon oxide insulating (SOI) substrates, and the employed microfabrication technique enabled to achieve gate-controlled emission currents and good signal amplification. The AC voltage gain resulted in agreement with the theoretical model.

In [117] a basic circuit building block consisting of an integrated differential amplifier is described in details. The device is based on an array of vertically configured nanodiamond emitters integrated with partition gates and split anodes. The dual-mask fabrication procedure involved the steps of nitrogendoped nanodiamond deposition into micropatterned molds on SOI substrates and the mold-transfer, followed by partition of the Si gate and formation of individual nanodiamond FETs. The SEM image of two adjacent nanodiamond-based VFETs is reported in **Fig. 21** along with the image of a vertically configured cathode and details of the emitting surface. The inset of **Fig 21** evidences a single emitter cathode with ultrasharp apex. Such nitrogen-incorporating ultrasharp diamond emitters have been produced by plasma-enhanced CVD from CH<sub>4</sub>/H<sub>2</sub>/N<sub>2</sub> mixtures. The device fabricated following the procedure reported in [114] matched well the characteristics of a VFET, with a low gate turn-on voltage and negligible gate intercept current.

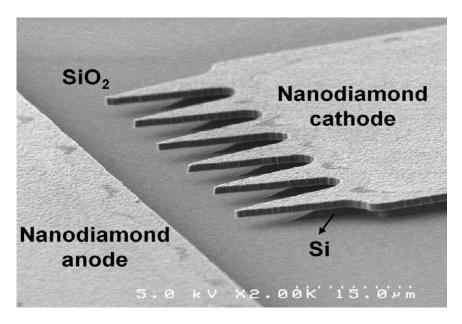


**Fig.21:** FESEM image of: (a) a pair of nanodiamond vacuum field emission transistors (ND-VFETs) (top-viewed); (b) a part of a ND-VFET with insets showing a higher magnification and a single ND cathode with self-aligned Si gate. Reprinted with permission from Ref. [117].

Nanodiamond can be also used to fabricate notable non-contact RF transducers [118]. Current densities up to 500 nA per nanodiamond tip at applied bias of 30 V, have been achieved by processing B-doped 200 nm thick layers. In Ref. [118] it is described an innovative design that, through the choice of a suitable chip architecture and the engineering of the material, allowed the realization of a low-barrier electron emitter and of a RF piezo-actuator in the same microsized device.

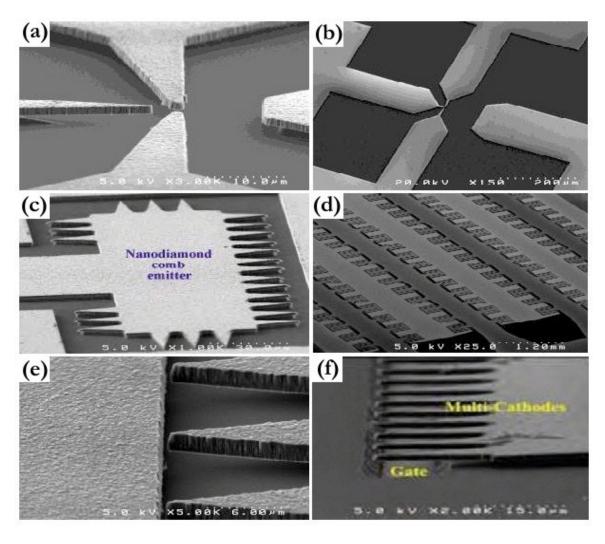
The concept of FE from nanodiamond has been also proposed for engineering flat panel X-ray sources [119]. The cathode prototype consisted of a FE array of N-containing ultrananocrystalline deposits, fabricated using conventional microfabrication techniques. A current density of about 6 mA/cm² at applied field of 10 V/µm has been produced. The experimental data were compared with the output of simulations in order to define alternative gate configuration and to assure a beam of highly collimated electrons. Such flat-panel X-ray sources are being tested for medical and industrial imaging applications.

Material properties, device structure and fabrication process are different aspects to be taken into consideration when dealing with the fabrication of last generation cold cathodes. Several alternative concepts of nanodiamond-derived vacuum emitters have been recently proposed and tested in order to realize devices with high speed, low power dissipation, robustness and long working life. An advantageous configuration is that of the planar lateral emission, firstly developed at the Diamond Laboratory of Vanderbilt University [120]. As illustrated in [121,122], nitrogen-doped diamond films with grain size 5-10 nm, obtained by CH<sub>4</sub>/H<sub>2</sub>/N<sub>2</sub> MW plasma enhanced CVD on SOI substrates, were patterned by RIE to fabricate a lateral FE diode device equipped with 6 fingers (inter-electrode separation: 3 μm). The lateral diode exhibits a turn-on field of 1.9 V/μm, and a high emission current of 1.1 mA (~ 183 μA current per finger) at an applied field of ~ 30 V/μm. The emission current was found stable over 10 h with ~ 4% fluctuation. Using the same process and by varying the electrode geometry, a series of lateral diodes, triodes and transistors were thereafter fabricated [120,121]. A 6-finger nanodiamond lateral field emission diode [123] is reported in Fig.22. The vacuum-packaged device produced a current of over 3 µA at about 10 V/µm applied field, and exhibited a linear F-N plot. The operating characteristics of monolithic vacuum devices fabricated applying such technology were not affected by X-ray irradiations up to 20 Mrad or high fluences up 4 10<sup>13</sup> neutrons/cm<sup>2</sup> [123].



**Fig.22:** SEM picture of a "6-finger" lateral nanodiamond vacuum emission diode (2000x). Reprinted with permission from Ref. [123].

Frontier researches are nowadays focused on the design of a variety of vacuum field emission micro- and nano-devices with novel configurations, such as lateral emitting diodes, triodes, transistors and integrated amplifiers [124]. Some examples of nanodiamond-based lateral field emission devices can be viewed in **Fig. 23.** 



**Fig.23:** Examples of nanodiamond vacuum lateral devices. SEM images of: (a) triodes; (b) transistors; (c) comb diode arrays; (d) large integrated diode arrays; (e) nano-gap diode arrays, and (f) commongated triodes. Reprinted with permission from Ref. [124].

The logical gates represent a further exciting envisaged application of the field emission from diamond [125]. Patterning highly conductive 1  $\mu$ m thick films (5-10 nm grain size) by a pure O<sub>2</sub> plasma using an Al mask, allowed to define the lateral cathode and anode structures of vacuum microelectronic OR logic gates [126]. It has been demonstrated that the input/output logic values and the OR response can be optimized by increasing the emission area and the number of emission sites in the fingered structures.

Also in another outstanding technological area, namely that of accelerators and free electron laser, the technology of nanodiamond emitters come to play an attractive role. The characteristics of FE in RF fields have been reviewed by X. Li et al. [127]. The aim of this research was to demonstrate the feasibility to use field emitter arrays and planar emitters based on diamond to drive accelerators and FEL. Experimental studies performed by installing a single cell test cavity have been compared with results obtained by simulations. The investigation indicated that low emittance and low energy spread bunches can be produced for amplitudes of the electric field on the cathode surface in the 60-90 MV/m range. Electric fields up to 90 MV/m could be achieved when installing a half-cell S-band in the RF gun, making it possible to obtain high current electron bunches to drive a compact THz -FEL facility.

## **CONCLUSIONS**

In the last decade, the class of nanodiamonds has been more and more investigated in the framework of the research activities looking for efficient and robust emitting materials with outstanding ability to work also in hostile environments.

The unique advantages of nanodiamond and related materials place them at the forefront of the R&D activities related to cold cathodes, despite the fact that electron emission from diamond cannot reach the current densities measured for carbon nanotubes

First of all, as for all the devices operating by the field emission mechanism, the nanodiamonds—based cold cathodes show an almost instantaneous response to field variations. Moreover, due to its structural high stability, diamond can carry high current densities for long time without any degradation. Additional benefits are the chemical inertness and tolerance to high radiations doses.

The present paper surveys the state-of-the-art of material design and procedures, putting in evidence those one more promising for building highly efficient field emitting systems, for a wide set of near-term and future technologies.

The various applications require not only the capability to generate nanodiamonds with specific intrinsic properties in terms of conductivity and of field emission, but also to retain strong control over the organization of the nanostructures in predefined architectures. In this context, we attempted to illustrate the many exciting research challenges and technological opportunities related to the fabrication of cold cathodes based on nanodiamonds.

The first consideration is that the downsizing of the diamond grains is, in any case, able by itself to guarantee noticeable improvements of the field emission from the diamond. It is indeed well known that polycrystalline layers formed by microsized crystallites are characterized by very low densities of emitted current, also at rather high applied fields. Understanding the changes in the emission features as the grain dimensions decrease, has been an important and widely pursued research issue, and the downscaling of diamond is now considered the first focal goal to be reached by the use of suitable fabrication processes or post-synthesis procedures.

The next point concerns the shape of the emitters. The FN law with its geometrical field enhancement factor  $\beta$ , points out that, independently on the material, the emission is enhanced when the material is modeled in pointed shapes. The ratio between height and radius curvature of the tips governs the increase of emission from tips with respect to that from plane deposits. All the experimental data obtained up today conform to the F-N equation.

However, in the case of diamond, the roadmap for the fabrication of alternative efficient devices impervious to temperature and radiations needs much more than the downsizing and the shaping in elongated nanostructures. In the process of preparing, characterizing and fabricating prototype devices with such nanomaterials, we learned that the emission is driven by the sp<sup>2</sup> content of the diamond samples. Here we are at the heart of the concept of field emission from the diamond phase: a graphitic component is essential to have reasonably good current densities. This is one of the rare cases in which, from phase purity, the functional properties of materials do not derive benefits, but rather drawbacks. As a matter of fact, since the first experimental investigations performed in the '90s on the relationship between emission behavior and nanostructure, diamond characterized by high phase purity has demonstrated to be a poor emitter. However, only recently direct observations of the emission sites allowed to verify the role of graphitic phases in making diamond a suitable field emitter. Electron emission is now confirmed to occur preferentially from the sp<sup>2</sup>-coordinated nanodomains that open very efficient conducting channels for electron transport and tunneling into diamond even at low applied fields.

As regards the sp<sup>2</sup> content, its intentional or unintentional presence is in any case ascribable to the synthesis procedures. Optimization of the electron emission from diamond is nowadays pursued using methodologies that allow to retain control over the structure at the nanoscale and to model both content and location of the sp<sup>2</sup> inclusions. Among the most widely used synthesis approaches to produce low dimensional diamond films, one can cite the growth of UNCD by plasma-assisted CVD from gaseous mixtures rich in inert gases. The small size of the diamond crystallites (2-5 nm) is the result of high secondary nucleation rates, promoted by the inert gases in a H-poor plasma. The presence of sp<sup>2</sup> phase at the grain boundaries of the UNCD films can be rationalized by considering that, in a H-poor plasma, this phase cannot be etched away efficiently.

Various strategies, mainly based on plasma-enhanced CVD, have been suggested to produce films with grain sizes > 10 nm. The graphitic deposits surrounding the crystallites assured in any case good emission features and these nanomaterials are candidates for the assembling of highly performing cold cathodes.

Moving from such strategies towards a completely different approach, namely the implantation of metal ions into nanocrystalline diamond films, one discovers that the performances of these last materials can be explained as well by a favorable combination of diamond and graphite phases. In effect, the ultimate result due to Cu, Fe or Au implantation is that to generate, during the metal clustering process, dense populations of graphitic nanoregions along the grain boundaries. The enhancement of the FE properties may thus be viewed as a secondary effect of the ion implantation, and directly ascribed to the presence of nanographites.

A successful category of emitting nanodiamonds refers to the 1D structures, that are currently produced by direct CVD techniques or by post-synthesis treatments using high energy sources.

A large variety of techniques and of corresponding set-up have been experimented aiming to obtain materials with increased emitting properties, and intensive research efforts are still devoted to the engineering of emitters with designed features. One must consider, however, that the patterning of diamond in sharpened forms is always accompanied by the presence of sp<sup>2</sup> phases, produced by the synthesis or post-synthesis techniques. This unavoidable graphitic component comes to play a prominent role also in the case of pointed emitters, and the control of the sp<sup>2</sup> inclusions is nowadays a fundamental issue pursued in several laboratories.

It is to be noted that the shaping of diamond in 1D nanostructures is gaining a quite important place also for other applications, such as DNA sensing [128], bio- and electro-chemistry [87], gas sensing [129] and quantum information [130].

The last considerations regard the practical implementations of FE-based innovative devices that take advantage from the outstanding properties of nanodiamond. The analysis of the more recent literature evidences that, in the search for new ways to fabricate cold cathodes, synthesis processes, post-synthesis procedures and assembling methodologies are no more independent issues to be faced one-by-one, but rather entangled aspect of the same task. This approach is allowing to produce a new generation of non-conventional and highly performing vacuum field emission devices, with unlimited possibilities of use in areas related to space, nuclear reactors, accelerators.

As regards space applications, the use of diamond-based cold cathodes is being considered not only for the substitution of conventional flat panel displays and other electron-beam vacuum devices sensible to cosmic rays, but also for propellant ionization and ion beam neutralization in electrical propulsion systems. Technological demands of the space community is also leading to the testing of these robust and efficient electron emitters for the fabrication of on-board mounted devices, such as ionization sources for compact spacecraft mass spectrometers and for fabrication of miniaturized X-ray tubes.

High power pseudo-spark switches based on nanodiamond cathodes are tested to substitute in perspective Thyratrons or Spark Gaps in high power excimer laser and pulse power modulators in linear accelerators.

In the field of advanced vacuum microelectronics for communications, researchers are deeply exploring bipolar devices and monolithic lateral microtriodes characterized by long working life also in high temperature and radiation harsh environment.

It is hoped that the results obtained so far could inspire further developments in designing new nanodiamond-based architectures and converting them into practical forms. The goal is to solve multisectorial technological issues, reducing the gap among research, industrialization and production.

## **REFERENCES**

- 1. R.H. Fowler, L.W.Nordheim, Proc. R. Soc. London, Ser. A 119 (1928) 173
- 2. C.A. Spindt, J. Appl. Phys. 39 (1968) 3504-3505
- 3. I. Brodie, C.A. Spindt, Adv. Electr. Electron Phys 83 (1992) 1
- 4. de Heer Walt, A. Chatelain, D. Ugarte, Science 270 (1995) 1179-1180
- **5.** K.B.K. Teo, E. Minoux, L. Hudanski, F. Peauger, J.P. Schnell, L. Gangloff, P. Legagneux, D. Dieumegard, G.A.J. Amaratunga, W.I. Milne, Nature 437 (2005) 968
- **6.** R.C. Smith, J.D. Carey, R.J. Murphy, W.J. Blau, J.N. Coleman, S.R.P. Silva, Appl. Phys. Lett. 87, (2005) 263105
- 7. W.K. Yi, T.W. Jeong, S.G. Yu, J.N. Heo, J.H. Lee, W. Kim, J. Yoo, J. Kim, Adv. Mater. 14 (2002) 1464-1468
- 8. K. Yu, Y. S. Zhang, F. Xu, Q. Li, Z. Q. Zhu, Q. Wan, Appl. Phys. Lett.88 (2006) 153123
- M.L. Terranova, S. Orlanducci, A. Fiori, E. Tamburri, V.Sessa, M. Rossi and A. Barnard, Chem. of Mater. 17 (2005) 3214-3220
- 10. S. Orlanducci, E. Tamburri, M.L. Terranova, M. Rossi, Chem. Vap. Dep. 14, 241 (2008)
- 11. Fiori, S. Orlanducci, V. Sessa, E. Tamburri, F. Toschi, M.L. Terranova, A. Ciorba, M. Rossi, M. Lucci, A.S. Barnard, J. Nanosci. Nanotechnol.8, 1989 (2008)
- 12. X. Xiao, J.W. Elam, S. Trasobares, O. Auciello, J. A. Carlisle, Adv. Mater. 17, 1496 (2008)
- 13. N. Shankar, N.G. Glumac, M.F. Yu, S.P. Vanka, Diam. Relat. Mater. 17, 79 (2008)
- **14.** V. Guglielmotti, S. Chieppa, S. Orlanducci, E. Tamburri, F. Toschi, M.L. Terranova, M. Rossi, Appl. Phys. Lett. 95 (2009) 222113
- 15. A.Vul', K. Reich, E. Eidelman, M.L. Terranova, A. Ciorba, S. Orlanducci, V. Sessa, M. Rossi, Adv. Sc. Lett. 3 (2010) 110-116
- 16. Y. Zou, P.W. May, S.M.C. Vieria, N.A. Fox, J. Appl. Phys. 112 (2012) 044903
- 17. K.J. Sankaran, K. Srinivasu, K.C. Leou, N.H. Tai, I.N. Lin, Appl. Phys. Lett 103 (2013) 251601
- 18. L. Yang, Q. Yang, C. Zhang, Y.S. Li, Thin Solid Films 549 (2013) 42-45
- 19. D. Varshney, A.V. Sumant, O. Resto, F. Mendoza, K.P. Quintero, M. Ahmadi, B.R. Weiner, G. Morell, Carbon 63 (2013) 253-262
- **20.** T. Chang, S. Kunuku, K.J. Sankaran, K.C. Leou, N. Tai I.N. Lin, Appl. Phys.Lett 104 (2014) 223106
- 21. F.J. Himpsel, J.A. Knapp, J.A. Van Vechten, D.E. Eastman, Phys. Rev B 20 (1979) 624
- **22.** S. Gildenblat, P.E. Schmidt, "Diamond" Handbook series on Semiconductor Parameters vol 1, Ed by M. Levinstein (1996) Singapore World Scientific, 58-76
- 23. O. Shenderova, D. Brenner, R.S. Ruoff, Nano Lett. 3, 805 (2003)
- **24.** H. Watanabe, C. E. Nebel, S. Shikata, Science 324, 1425 (2009)

- 25. C.H. Hsu, S.G. Cloutier, S. Palefsky, J. Xu, Nano Lett. 10, 3272 (2010)
- **26.** I. Boscolo, S. Cialdi, A.Fiori, S. Orlanducci, V. Sessa, M.L. Terranova, A. Ciorba, M. Rossi, J. Vac. Science Tecn. 25, 1253-1258 (2007)
- 27. J. Robertson, Journal of Vacuum Science & Technology B 17(2) (1999) 659-665
- 28. A. Bolker, C. Saguy, M. Tordjman, R. Kalish, Phys. Rev B 88 (2013) 035442
- 29. C. Wang, A. Garcia, D.C. Ingram, M.E. Kordesh, Electron. Lett. 27 (1991) 1459
- 30. M.W. Geis, N.N. Efremov, J.D. Woodhouse, IEEE Electr. Device Lett. 12 (1991) 456
- 31. W. Zhu, P. Kochanski, S. Jin, L. Seibles, J. Vac. Sci. Technol. B14(3) (1996) 2011-2019
- **32.** M.L. Terranova, V. Sessa, S. Piccirillo, M. Rossi, G. Micocci, A. Serra, A. Tepore, Appl. Phys. Lett 75, 379-381 (1999)
- **33.** A. Serra, D. Manno, T. Siciliano, G. Micocci, A. Tepore, M. Rossi, M.L. Terranova, V. Sessa, S. Piccirillo, S. Orlanducci, J. Appl. Phys. 94, 416-422 (2003)
- **34.** A. Joshi, R. Nimmagadda, J. Mater. Res. 6 (1991) 1484
- 35. B.R. Stoner, G.J. Tessmer, D.L. Dreifus, Appl. Phys. Lett. 62 (1993) 1803
- **36.** S. Bhattacharyya, O, Auciello, J. Birrel, J.A. Carlisle, L.A. Curtiss, A.N. Goyette, D. M. Gruen, A.R. Krauss, J. Schlueter, A. Sumant, P. Zapol, Appl. Phys. Lett.79 (2001) 1441-1443
- 37. F.A.M. Kõck, J.M. Garguilo, R.J. Nemanich, Diamond Rel. Mater. 13 (2014) 1022-1025
- 38. D. Pradhan, I.N. Lin, Appl. Mater. Interfaces 1, 1444 (2009)
- 39. S.A. Lyashenko, A.P. Volkov ,R.R. Ismagilov, A.N. Obratsov, Techn. Phys. Lett. 35 (2009) 249-252
- 40. K. Subramanian, W.P. Kang, J.L. Davidson, B.K. Choi, M. Howell, Diamond Rel Mater. 15 (2006) 1994-1997
- **41.** O. Ivanov, V. Isaev, D. Radished, M. Lobaev, A.L. Visharev, V. Chernov, A. Kozlov, J.L. Hirshfield, IEEE Transactions on Plasma Science 39(1) (2011) 2794-2795
- **42.** K.Y. Teng, H.C. Chen, H.Y Chiang, C.C. Horng, H.F. Cheng, K.J. Sankaran, N.H. Tai, C.Y. Lee, I.N. Lin, Diamond Rel Mater. 24 (2012) 126-133
- 43. A.V. Karabutov, V.D. Frolov, V.I. Konov, Diamond Rel. Mater. 10 (2001) 840-846
- 44. A. Wisitsora, W.P. Kang, J.L. Davidson, D.V. Kerns, Appl. Phys. Lett. 71 (23) (1997) 3394-3396
- **45.** J.E. Butler, A.V. Sumant, Chem Vap, Dep. 14 (2008) 146-160
- **46.** D.M. Gruen, Ann. Rev. Mater. Sci 29 (1999) 211
- 47. T.D. Corrigan, A.R. Krauss, D.M. Gruen, O. Auciello, R.P.H. Chang, MRS Symposium Proc. 593 (2000) 233
- 48. D.M. Gruen, MRS Bulletin October 2001, 771-776
- **49.** A.R. Krauss, O. Auciello, M.Q. Ding, D.M. Gruen, Y. Huang, V.V. Zhirnov, E.I. Givargizov, A. Breskin, R. Cheken, E. Shefer, V. Konov, S. Pimenov, A. Karabutov, A. Rakhimov, N. Suetin, J. Appl. Phys. 89 (2001) 2958

- **50.** V.D. Frolov, S.M. Pimenov, V.I. Konov, V.I. Polyakov, A.I. Rukovishnikov N.M. Rossukanyl, J.A. Carlisle, D.M. Gruen, Surf. Interface Anal. 36 (2004) 449-454
- **51.** D. Zhou, A.R. Krauss, L.C. Qin, T.G. McCauley, D.M. Gruen, T.D. Corrigan, R.P.H. Chang, H. Gnaser, J.Appl. Phys. 82 (1997) 4546-4550
- 52. T.D. Corrigan, D.M. Gruen, A.R. Krauss, P. Zapol, R.P.H. Chang, Diamond Rel. Mater. 11 (2002) 43-48
- 53. J. Birrel, J.A. Carlisle, O. Auciello, D.M. Gruen, J.M. Gibson, Appl. Phys.Lett. 81 (2002) 2235-2237
- **54.** J. Birrel, J.E. Gerbi, O. Auciello, J.M. Bibson, D.M. Gruen, J.A. Carlisle, J. Appl. Phys. 93 (2003) 5606-5612
- 55. R. Arenal, P. Bruno, D.J. Miller, M. Bleuel, J. Lai, D.M. Gruen, Phys. Rev. B 75 (2007) 195431
- 56. K.Okano, S. Koizumi, S.R.P. Silva, G.A.J. Amaratunga, Nature 381 (1996) 140-141
- **57.** A. Ilie, A.C. Ferrari, T. Yagi, S.E. Rodil, J. Robertson, E. Barborini, P. Milani, J. Appl. Phys. 90 (4) (2001) 2024- 2032
- **58.** S. Orlanducci, A. Fiori, V. Sessa, E. Tamburri, F. Toschi, M.L.Terranova, J Nanosc. Nanotechn. 8 (2008) 1-7
- **59.** Y.C. Lin, K.J. Sankaran, Y.C. Chen, C.Y. Leee, H.C. Chen, I.N. Lin, N.H. Tai, Diamond Rel. Mater. 20 (2011) 191-195
- **60.** K.J. Sankaran, J. Kurian, H.C. Chen, C.L. Dong, C.Y. Lee, N.H. Tai, I.N. Lin, J. Phys. D: Appl. Phys. 45 (2012) 365303
- 61. P. Deak, B. Aradi, M. Kaviani, T. Frauenheim, A. Gali, Phys Rev B 89 (2014) 075203
- **62.** V.P. Mammana, T.E.A. Santos, A. Mammana, V. Baranauskas, H.J. Ceragioli, A.C. Peterlevitz Appl. Phys. Lett 81 (2002) 3470
- 63. V. Baranauskas, M. Fontana, H.J. Ceragiolo, A.C. Peterlevitz, Nanotechnology 15 (2004) S678-S683
- 64. S.A. Lyashenko, A.P. Volkov, R.R. Ismagilov, A.N. Obratsov, Techn. Phys. Lett. 35 (2009) 249
- 65. H.F.Cheng, K.Y.Teng, H.C.Chen, G.C. Tzeng, C.Y Tang, I.N. Lin Surf.& Coating Technology 228 (2013) S175-S178
- **66.** A. Saravanan, B.R. Huang, K.J. Sankaran, C.L.Dong, N.H. Tai, I.N. Lin, Appl. Phys.Lett 104 (2014) 181603
- 67. V.V. Chernov, O.A. Ivanov, V.A. Isaev, D.B. Rasdishev, A.L. Visharev, A.V. Kozlov, Diamond Rel Mater. 37 (2013) 87-91
- 68. K.J. Sankaran, H.C. Chen. C.Y. Lee, N.H. Tai, I.N. Lin, Appl. Phys. Lett. 24 (2012) 241604
- **69.** K.J. Sankaran, H.C. Chen, B. Sundaravel, C.Y. Lee, N.H. Tai, I.N. Lin, Appl. Phys. Lett. 102 (2013) 061604
- 70. K.J. Sankaran, K. Panda, B. Sundaravel, N.H. Tai, J. Appl. Phys. 115(6) (2014) 063701

- 71. K. Panda, B. Sundaravel, B.K. Panigrahi, H.C. Chen, P.C. Huang, W.C. Shih, S.C. Lo, L.J. Lin, C.Y. Lee, I.N. Lin, J. Appl. Phys. 113 (2013)
- 72. K.J. Sankaran, H.C. Chen, K. Panda, B. Sundaravel, C-Y. Lee, N-H-Tai,I-N. Lin, ACS Applied Mater Interfac. 6(7) (2014) 4911-4919
- 73. A. S. Barnard, Rev. Adv. Mater. Sci. 6, 94, (2004) 15
- 74. S.B. Tian, Y.L. Li, X.X. Xia, C.Z. Gu, J.J. Li, Physica E 43 (2011) 1902
- 75. C.E. Nebel, N. Yang, H. Uetsuka, E. Osawa, N. Tokuda, O. A. Williams Diamond & Related Materials 18, 910–917, (2009)
- 76. X. Wang, L.E. Ocola, R.S.Divan, A. Sumant, Nanotechnology 23 (7) (2012) 075301
- 77. H. Masuda, T. Yanagishita, K. Yasui, K. Nishio, I. Yagi, T. N. Rao, A. Fijishima, Adv. Mater. 13, 247, (2001) 11
- **78.** M.Y. Chen, K.Y. Wu, J. Hwang, M.T. Chang, L.J. Chou, C.S. Kou, Nanotechnology 18 (2007) 455706
- **79.** S. Orlanducci, V. Guglielmotti, I. Cianchetta, V. Sessa, E. Tamburri, F. Toschi, M.L. Terranova, M. Rossi, Nanosc. Nanotech. Lett. 4 (2012) 338–343
- **80.** M. Sugawara, Plasma Etching: Fundamentals and Applications, Oxford University Press, New York, 1998
- **81.** R.J. Shul, S.J. Pearton (Eds.), Handbook of Advanced Plasma Processing Techniques, Springer, Berlin, NY, 2000
- 82. K. Ostrikov, Plasma Nanoscience, Wiley-VCH, Weinheim, 2008
- 83. R.M. Sankaran (Ed.), Plasma Processing of Nanomaterials, CRC Press, Boca Raton, 2011
- 84. G.S. Sandhu, W.K. Chu, Appl. Phys. Lett. 55 (1989) 437
- 85. B.R. Stoner, G.J. Tessmer, D.L. Dreifus, Appl. Phys. Lett. 62 (1993) 1803
- 86. Y. Ando, Y. Nishibayashi, A. Sawabe, Diamond Relat. Mater. 13 (2004) 633
- 87. W. Smirnov, A. Kriele, N. Yang, C.E. Nebel, Diamond Relat. Mater. 19 (2010)186-189
- 88. F. Weigl, S. Fricker, H-G.Boyen, C. Dietrich, B. Kolowski, A. Plettl, O. Pursche, P. Zienann, P. Walther, C. Hartmann, M. Ott, M. Moeller, Diamond Rel. Mater 15 (2006) 1689-1694
- 89. J.Y. Lin, Z.C. Li, C.Y. Chen, L.J. Chou, J.C. Hwang, C.S. Kou, Diamond Rel. Mater 20 (2011) 922-926
- 90. S. Kunuku, K.J. Dankaran, C.Y. Tsai, W.H. Chang, N.H. Tai, K.C. Leou, I.N. Lin, ACS Applied Mater Interf. 5(15) (2013) 7439-7449
- 91. W.J. Zhang, X. Jiang, Y.B. Xia, J. Appl. Phys. 82 (1997) 1996
- **92.** Y.S. Zou, K.L. Ma, W.J. Zhang, Q. Ye, Z.Q. Yao, Y.M. Chong, S.T. Lee, Diamond Relat. Mater. 16 (2007) 1208

- **93.** Y.F. Tzeng, K.H. Liu, Y.C. Lee, S.J. Lin, I.N. Lin, C.Y. Lee, H.T. Chiu, Nanotechnology 18 (2007) 435703
- **94.** J.Y. Lin, S.H. Wang, T.T. Chen, C.Y. Chen, L.J. Chou, J.C. Hwang, C.S. Kou, J. Electrochem. Soc. 158 (2011) D426
- **95.** W.J. Zhang, Y. Wu, W.K. Wong, X.M. Meng, C.Y. Chan, I. Bello, Y. Lifshitz, S.T. Lee, Appl. Phys. Lett. 83 (2003) 3365
- 96. W.J. Zhang, X.M. Meng, C.Y. Chan, Y. Wu, I. Bello, S.T. Lee, Appl. Phys. Lett. 82 (2003) 2622
- 97. W.J Zhang, Y.Wu, C.Y. Chan, W.K. Wong, X.M. Meng, I. Bello, Y. Lifshitz, S.T. Lee, Diamond Rel Mater. 13 (2004) 1037-1043
- 98. Q. Wang, Z.L. Wang, J.J. Li, Y. Huang, Y.L. Li, C.Z. Gu, Z. Cui, Appl. Phys. Lett. 89 (2006) 063105
- 99. K. Panda, K.J. Sankaran, B.K. Panigrahi, N.H. Tai, I.N. Lin, ACS Appl. Mater Interf. 6(11) (2014) 8531-8541
- 100. V. Chatterjee, R. Harniman, P.W.May, P.K. Barhai, Appl. Phys. Lett 104 (2014) 171907
- 101. Z.L. Wang, Q. Wang, H.J. Li, J.J. Li. P. Xu, Q. Luo, A.Z. Jin, H.F. Yang, C.Z. Gu, Science Technol. of Adv. Mater. 6 (2005) 799-803
- 102. Z.L. Wang, Q. Luo, J.J. Li, Q. Wang, P. Xu, Z. Cui, C.Z. Gu, Diamonfd Rel. Mater. 15 (2006) 831-634
- 103. K.J. Sankaran, N.H. Tai, I.N. LiN, Appl. Phys.Lett. 104 (2014) 031601
- 104. V.N. Mochalin, O. Shenderova, D. Ho and Y. Gogotsi, Nat. Nanotechnol., 2012, 7(1) 11-23
- 105. A.I. Lymkin, E.A. Petrov, A.P.Ershov, G.V. Sakovitch, A.M. Stayer, V.M. Titov, Dokla. Akad. Nauk USSR 302 (1988) 611-613
- 106. N.R. Greiner, D.S. Philips, J.D. Johnson, F. Volk, Nature 333 (1988) 440-442
- 107. V.V. Zhirnov, O.A. Shenderova, D.L. Jaeger, A. Tyler, A.A. Areskin, D.W. Brenner, J.J. Hren, Phys. Solid State 46 (2004) 657-651
- 108. A.S. Barnard, M. Sternberg J. Mater. Chem., 2007, 17, 4811–4819
- **109.** J.Y. Raty, G. Galli, Nat Mater 2(12), (2003) 792-795
- **110.** O. Shenderova, G. McGuire Handbook of Nanomaterials, Ed Yu Gogotsi (Boca Raton, CRC Press) (2006) p. 201
- 111.M. Baidakova, AA. Yu. Vul', J. Phys. D: Appl. Phys. 40 (2007) 6300
- **112.** O.A. Shenderova, D.M. Gruen: "Nanocrystalline Diamond: synthesis, properties and applications "Google e-book 2012"
- **113.** Detonation Nanodiamonds: Fabrication, Properties and Applications. Proc 1st Int. Symp. 2003, St. Petersburg

- **114.** D.M. Gruen, O. Shenderova, A.Y. Vul', Synthesis, Properties and Applications of Ultrananocrystalline Diamond, vol. 192 (Springer, 2005)
- **115.** A. Aleksenskiy, M. Baidakova, V. Osipov, A.Y. Vul' The Fundamental Properties and Characteristics of Nanodiamonds in "Nanodiamonds" Ed by D. Ho, Springer (2010) 55-77
- 116. S.H. Hsu, W.P. Kang, J.L. Davidson, J.H. Huang, D.V. Kerns, J. Appl. Phys. 111 (2012) 114502
- 117. S.H. Hsu, W.P. Kang, J.L. Davidson, J.H. Huang, IEEE Transactions on Electron Devices 60 (2013) 487-493
- 118. N. Heidrich, J. Hees, V. Zuerbig, D. Iankov, W. Pletdchen, R.H. Dah, B. Rasynor, L. Kirste, C.E. Nebel, O. Ambacher, V. Lebedev, Transducers & Eurosensors (2013) 218-221
- 119. C.M. Posada, E.J. Grant, R. Divan, A.V. Sumant, D. Rosenmann, L. Start, H.K. Lee, C.H. Castano, J. Appl. Phys. 115 (13) (2014) 134506
- **120.** W.P. Kang, J.L. Davidson, A. Wisitsora, M. Howell, A. Jamaludin, Y.M. Wong, K.L. Soh, D.V. Kerns, J. Vac. Sci. Technol. B 21 (2003) 192-195
- **121.** K. Subramanian, W.P. Kang, J.L. Davidson, W.H. Hofmeister, Diamond Rel Mater.14 (2005) 404-410
- 122. K. Subramanian, W.P. Kang, J.L. Davidson, W.H. Hofmeister, B.K. Choi, M. Howell, Diamond Rel. Mater. 14 (2005) 2099-2104
- **123.** K. Subramanian, W.P. Kang, J.L. Davidson, N. Gosh, K.F. Galloway, Microelectronic Engineering 88 (2011) 2924-2929
- 124. W.P. Kang, S.H. Hsu, N. Ghosh, J.L. Davidson, J.H. Huang D.V. Kerns, 25th IVNC-International Vacuum Nanoelectronic Conference (2012) 1-2
- **125.** W. Prost, U. Auer, F.J. Tegude, C. Pacha, K.F. Goser, G. Janssen, T van der Roer, Int. J. Circuit Theory Appl. 28 (2000)
- 126. N. Ghosh, W.P. Kang, J.L. Davidson Diam. Rel Mater. 23 (2012) 120-124
- 127. X. Li, M. Li, L. Dan, Y. Liu, C. Tang, Phys. Rev ST Accel. Beams, 16 (2013) 123401
- **128.** N. Yang, H. Uetsuka, O.A. Williams, E. Osawa, N. Tokuda, C.E. Nebel, Phys. Status Solidi(A) 206 (9) (2009) 2048-2056
- 129. C. Lu, Y. Li, S. Tian, W.Li, C. Gu, Microelectr. Engineering 88(8) (2011) 2319-2321
- 130. B.J.M. Hausmann, M. Kahn, Y. Zhang, T.M. Babinec, K. Martinick, M. McCutcheon, P.R. Emmer M. Loncar, Diamond Rel. Mater. 19(5-6) (2010) 621-629

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